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In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
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January 29, 2004

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450   Attorney Reference: AI 322

Re: New Patent Application of: Masaru TAKAISHI
Title: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

Sir:

Please find attached hereto an application for patent that includes:
[x]   Specification, Claims and Abstract (23 Pages)
[x]   3 Sheets of Formal Drawings (Fig. 1 through Fig. 2e)
[x]   Inventor's Declaration and Power of Attorney (3 Pages)
[x]   Assignment document with cover page (2 Pages)
[x]   Claim for priority and Priority document
[x]   Information Disclosure Statement, Form PTO-1449, and copy of one cited reference
[x]   Form PTO-2038 (1 Page)
[x]   Fee (see formula below)

Basic Fee $770/385 $ 770.00
Additional Fees:

Total number of claims: _8_
in excess of 20: _0_ times $18/9 $ 0.00

Number of independent claims: _1_
    in excess of 3: _0_ times $86/43 $ 0.00

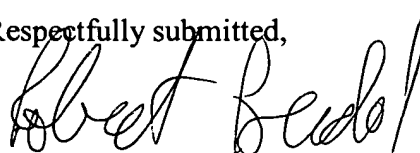Multiple Dependent Claims $290/145 $ 0.00

Recording Fee $40. $ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION $ **810.00**

In the event there is attached hereto no credit card form PTO-2038 or check, or there is an insufficient amount, please charge the fee to our Account No. 18-0002 and notify us accordingly.

The right of priority is claimed under 35 USC §119 of Japanese Application No. 2003-051572, filed February 27, 2003.

Respectfully submitted,

January 29, 2004
Date
RHB:tz

Robert H. Berdo, Jr. (Reg. No. 38,075)
(Customer No. 23995)